

Knobbe Martens Olson & Bear LLP

Intellectual Property Law

2040 Main Street
Fourteenth Floor
Irvine, CA 92614
Tel 949-760-4004
Fax 949-760-8502
www.kmob.com

Mincheol Kim
mkim@kmob.com

August 13, 2007

CERTIFICATE OF EFS WEB TRANSMISSION

I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

August 13, 2007

(Date)



Mincheol Kim, Reg. No. 51,306

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Title: DEVICE AND METHOD OF CORRECTING EXPOSURE DEFECTS IN
PHOTOLITHOGRAPHY
Letters Patent No. 6,812,999
Issued: November 2, 2006
Our Reference: MICRON.100C1

Dear Sir:

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP



Mincheol Kim
Registration No. 51,306
Customer No. 20,995

Enclosures
4131007:jmo
081007

San Diego
619-235-8550

San Francisco
415-954-4114

Los Angeles
310-551-3450

Riverside
951-781-9231

San Luis Obispo
805-547-5580